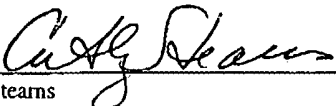


Corres. and Mail  
**BOX AF**

PATENT  
RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1752

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 27, 2004.*

  
Cathy Stearns

OK to enter 9-16-04 yet

Appl No.	: 10/092,846	Confirmation No. 9449
Applicant	: Beom-Wook Lee	
Filed	: March 7, 2002	
Title	: CHEMICALLY AMPLIFIED NEGATIVE PHOTORESIST, AND PHOTORESIST COMPOSITION	
TC/A.U.	: 1752	
Examiner	: Yvette C. Thornton	
Docket No.	: 47769/DBP/Y35	
Customer No.	: 23363	

**AMENDMENT AFTER FINAL ACTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Post Office Box 7068  
Pasadena, CA 91109-7068  
August 27, 2004

Commissioner:

In response to the Office action of May 27, 2004, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.